

Docket:  
90065.000701/17732.6357.003

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

Applicant:	Jifa Hao, et al.	)	Examiner:
		)	Unknown
Serial No.:	TBA	)	
		)	
Filed:	Filed Herewith	)	Art Unit:
		)	2814
For:	DENSE TRENCH MOSFET WITH DECREASED	)	
	ETCH SENSITIVITY TO DEPOSITION AND	)	
	ETCH PROCESSING	)	
		)	
		)	

**INFORMATION DISCLOSURE STATEMENT**


Mail Stop: PATENT APPLICATION  
Commissioner for Patents and Trademarks  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR §1.97 - §1.98, Applicant hereby brings to the attention of the United States Patent and Trademark Office, the references listed on the attached Form PTO-1449. These references are relevant because they were cited in corresponding U. S. patent application serial number 10/044,220, filed November 20, 2001.

Respectfully submitted,

7/11/03  
\_\_\_\_\_  
Date

  
\_\_\_\_\_  
Thomas R. Fitzgerald, Esq.  
Registration No. 26,730

THOMAS R. FITZGERALD, ATTORNEY  
Reynolds Arcade Bldg., Suite 210  
16 East Main Street  
Rochester, New York 14614-1803  
Telephone: (585) 454-2250  
Facsimile: (585) 454-6364

[illegible]

*If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.*